



FIS920000149US1 (00750426AA)

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BOX #AFIFICATION

RESPONSE UNDER 37 C.F.R. § 1.116
---EXPEDITE PROCEDURE---
EXAMINING GROUP 1765

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of
David C. Ahlgren et al.

Serial No.: 09/633,857

Group Art Unit: 1765

Filed: August 7, 2000

Examiner: R. Kunemund

For: IN-SITU MONITORING AND CONTROL OF GERMANIUM
PROFILE IN SILICON-GERMANIUM ALLOY FILMS AND
TEMPERATURE MONITORING DURING DEPOSITION OF
SILICON FILMS

Commissioner for Patents
United States Patent and Trademark Office
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AMENDMENT UNDER 37 C. F. R. §1.116

Sir:

In response to the Office Action mailed July 14,
2003, please amend the above-identified application as
follows:

Amendments to the specification begin on page
2 of this paper.

No amendments to the claims are presented in
this paper.

Remarks begin on page 3 of this paper.